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INFORMATION DISCLOSURE STATEMENT BY APPLICANT				Application Number	TBD
(use as many sheets as necessary)				Filing Date	Herewith
Sheet	1	of	1	First Named Inventor	Chang, et al.
				Art Unit	TBD
				Examiner Name	TBD
				Attorney Docket Number	TSM02-0658

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number - Kind Code ² (if known)			
A	US-3,677,634		07-18-1972	Mathisen	
B	US-3,712,813		01-23-1973	Ross, et al.	
C	US-4,734,345		03-29-1988	Nomura, et al.	
D	US-4,857,425		08-15-1989	Phillips	
E	US-4,966,428		10-30-1990	Phillips	
F	US-5,187,372		02-16-1993	Clube	
G	US-5,504,598		04-02-1996	Goto, et al.	
H	US-5,528,390		06-18-1996	Goto, et al.	
I	US-5,774,240		08-30-1998	Goto, et al.	
	US-				

FOREIGN PATENT DOCUMENTS					
Examiner Initials*	Cite No. ¹	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Country Code ³ - Number ⁴ - Kind Code ⁵ (if known)			
J	DT-1 331 076		09-19-1973	SIEMENS	

OTHER PRIOR ART – NON PATENT LITERATURE DOCUMENTS					
Examiner Initials*	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.			T ²
K	WOLF, STANLEY, Ph.D. and TAUBER, RICHARD N., Ph.D.; Silicon Processing for the VLSI Era, 2000; pp. 615-635; Volume 1: Process Technology Second Edition; Lattice Press, Sunset Beach, California.				
L	MÜTZEL, MARIO; "Building 3D Nanostructures with Holograms"; STP-Gateway; April 3, 2002; http://www.stp-gateway.de/Archiv/archiv475-e.html				
M	MARDER, SETH, et al.; "Materials Absorb Two Photons, Generate Acid on Cue"; UniSci Daily University Science News; May 13, 2002; http://unisci.com/stories/2002/0513023.htm				
N	STILES, LORI; "Cornell Researchers Collaborate on a Major Advance in Microfabrication"; Cornell Chronicle; May 16, 2002; http://www.news.cornell.edu/Chronicle/02/5.16.02/Ober-3D_fab.html				

Examiner Signature	<i>[Signature]</i>	Date Considered	12/06
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. ¹Applicant's unique citation designation number (optional). ²See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶Applicant is to place a check mark here if English language Translation is attached.

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